

Amendments to the Drawings:

The attached sheets labeled "Replacement Sheet" include changes to FIG. 4.

In the amended FIG. 4, symbol 11 is added to represent an interface between the substrate 64 and the frame layer 66, and symbol 12 is added to represent an
5 interface between the rotating device 52 and the combination of the substrate 64 and the frame layer 66.

The features have been clearly shown in the original drawings. So, no new matter is added.

REMARKS/ARGUMENTS

The specification and drawing have been correspondingly amended without adding new matters and will be explained as below.

5 In the amended specification and drawing, an interface I1 between the substrate 64 and the frame layer 66 is substantially perpendicular to an interface I2 between the rotating device 52 and the combination of the substrate 64 and the frame layer 66. These features have been clearly shown in the original drawings, so no new matter is added.

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Claims 1-5 are now present in this application. Claim 1 has been currently amended according to the amended specification and FIG. 4.

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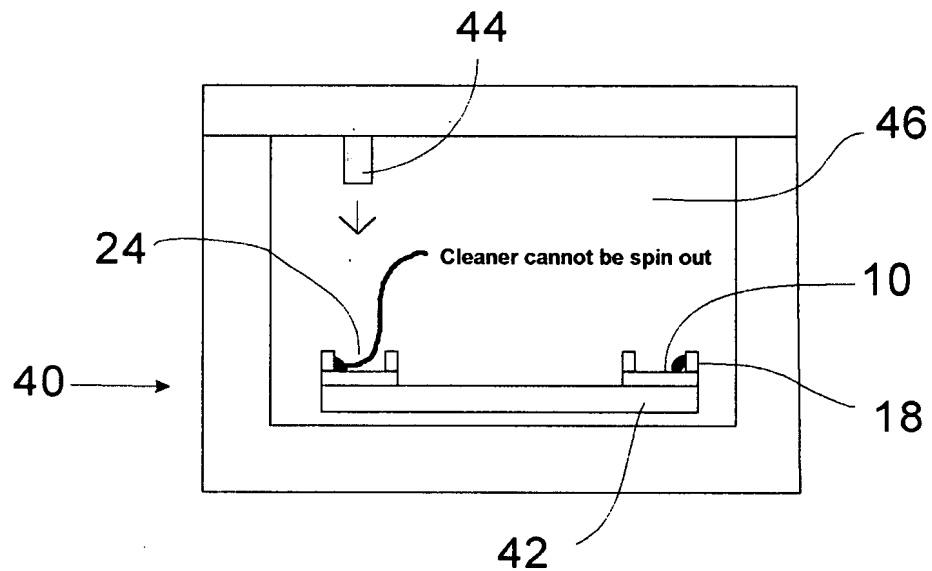
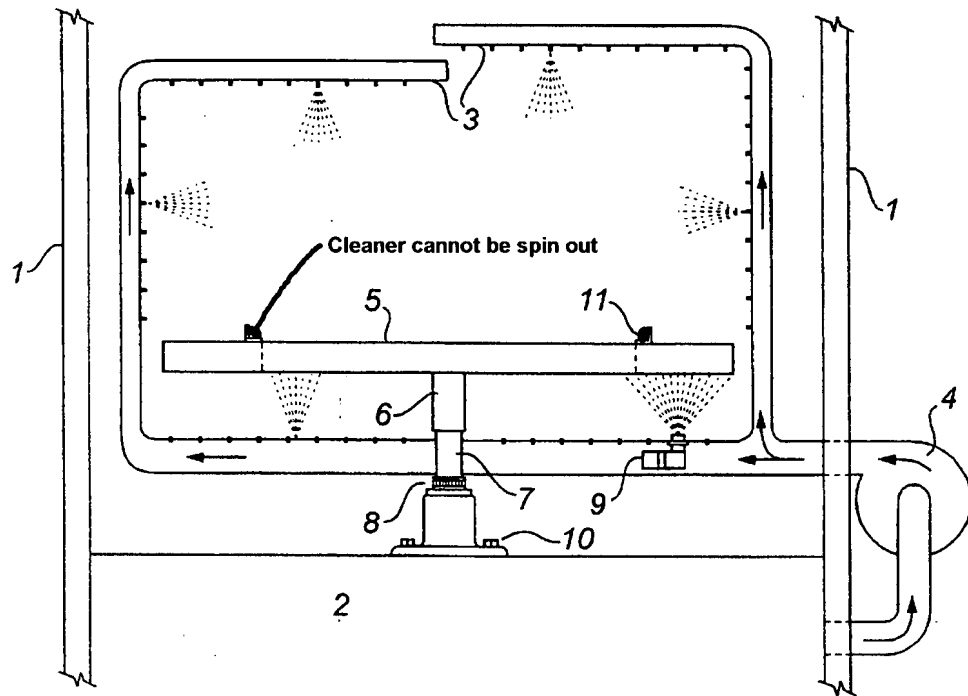
Claim rejections – 35 U.S.C. 102/103

The examiner rejects claims 1-5 under 35 U.S.C. 102(b) as being anticipated, or in the alternative, obvious under 35 U.S.C. 103(a) by Olechow (U.S. Patent No. 5,526,835).

20 Claim 1 has been amended to recite that an interface between the substrate (64) and the frame layer (66) is substantially perpendicular to an interface between the rotating device (52) and the combination of the substrate (64) and the frame layer (66).

25 In Olechow, however, an interface between the substrate (64) and the frame layer (66) is substantially *parallel to* an interface between the rotating device (52) and the combination of the substrate (64) and the frame layer (66). Also, the combination of the substrate (5) and the frame layer (11) is mounted on the rotation device (6) in a manner similar to that in FIG. 2 of this application. So, the cleaner in the chamber of the combination of the substrate and the frame layer cannot be spun out in FIG. 5 of Olechow and FIG. 2 of this application because the
30 cleaner has been blocked by the frame layer (11/18), as shown in the following drawings. This is why claim 1 is amended to restrict that the interface between

the substrate (64) and the frame layer (66) is substantially *parallel to* the interface between the rotating device (52) and the combination of the substrate (64) and the frame layer (66).



Considerations of the amended claim 1 and its dependent claims 2-5 are therefore politely requested.

5 In light of the above-mentioned amendments and remarks, Applicant now asserts that all of the grounds for rejections have been traversed or overcome by amendments, and that all of the present claims are in condition for immediate allowance. Applicant therefore requests reconsideration of the rejections, and solicits allowance of the present claims at an early date.

Thank you for your consideration.

Respectfully submitted,

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